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R. Kraya, J. Baskar, A. Arceo, H. Katz, N. Thakor



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Ultra-Low Resistivity Aluminum doped ZnO Thin Films on Flexible Substrates  
Using Sol-Gel Solution Deposition

Authors: R. Kraya<sup>1,\*</sup> rkraya@jhu.edu, J. Baskar<sup>1</sup>, A. Arceo<sup>2</sup>, H Katz<sup>2</sup>, N Thakor<sup>1</sup>

<sup>1</sup>Department of Biomedical Engineer, Johns Hopkins University, Baltimore, MD

<sup>2</sup>Department of Materials Science and Engineering, Johns Hopkins University,  
Baltimore, MD

\*Corresponding author.

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